FORM PTO-1449			Docket Number (Optional) 88519.0003		Application Number Not assigned		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION			Applicant Ken NAKAHARA				
(Use several sheets if necessary)			Filing Date February 4,	Filing Date February 4, 2004		Group Art Unit Not assigned	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
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FOREIGN PATENT DOCUMENTS							
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Al	2002-118330	04/19/02	Japan			Abstract	
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
A	Soon-Ku Hong et al., "Control of polarity of ZnO films grown by plasma-assisted molecular-beam epitaxy: Zn- and O-polar ZnO films on Ga-polar GaN templates", Applied Physics Letters, Vol. 77, No. 22, November 27, 2000, pp. 3571-3573						
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EXAMINER DATE CONSIDERED 10/3/05							
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in							